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**APPLICANTS**

Shih-Ho Lin, Jhubei City, TAIWAN;  
 Chung-Chang Chen, Hsin-Chu, TAIWAN;  
 Kei-Wei Chen, Taipei, TAIWAN;  
 Shih-Tzung Chang, Taichung, TAIWAN;  
 Chao-Lung Chen, Hsin-Chu, TAIWAN;  
 Po-Jen Shih, Tainan City, TAIWAN;  
 Yu-Ku Lin, Hsin-chu city, TAIWAN;  
 Ying-Lang Wang, Hsin-Chu, TAIWAN;

\*\* CONTINUING DATA \*\*\*\*\*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

**IF REQUIRED, FOREIGN FILING LICENSE GRANTED**

\*\* 04/23/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY TAIWAN	SHEETS DRAWING 2	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>[Signature]</i> Examiner's Signature	14 June 2006 Initials			

**ADDRESS**

TUNG & ASSOCIATES  
 Suite 120  
 838 W. Long Lake Road  
 Bloomfield Hills, MI48302

**TITLE**

Electropolishing method for removing particles from wafer surface

<b>FILING FEE RECEIVED</b> 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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